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PTO/SB/08A (08-00)

Substitute for form 1449A/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  <i>(use as many sheets as necessary)</i>				<i>Complete if Known</i>	
				Application Number	Not Yet Assigned
				Filing Date	Herewith
				First Named Inventor	Henrik JAKOBSEN
				Group Art Unit	Not Yet Assigned
				Examiner Name	Not Yet Assigned
Sheet	1	of	2	Attorney Docket Number	0715.0010C

[illegible][illegible]

Examiner Signature	<i>[Signature]</i>	Date Considered	08/15/05
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> Unique citation designation number.<sup>2</sup> See attached Kinds of U.S. Patent Documents.

<sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3).

<sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document.

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PTO/SB/08A (08-00)

Substitute for form 1449B/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  <i>(use as many sheets as necessary)</i>		<b>Complete if Known</b>			
		Application Number	Not Yet Assigned		
		Filing Date	Herewith		
		First Named Inventor	Henrik JAKOBSEN		
		Group Art Unit	Not Yet Assigned		
Examiner Name	Not Yet Assigned				
Sheet	2	of	2	Attorney Docket Number	0715.0010C

OTHER DOCUMENTS – NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
MM		DANIEL LAPADATU et al.; "Building of Silicon Mechanical Sensors by Bulk Micromachining and Anodic Bonding"; 1998 International Semiconductor Conference, Sinaia, Romania October 6-10, 1998; IEEE, Vol. 1; pages 33 – 44.	
MM		A.V. CHAVAN et al.; "A Monolithic Fully-Integrated Vacuum-Sealed CMOS Pressure Sensor"; Proceedings of the IEEE 13 <sup>th</sup> Annual International Conference; Miyazaki, Japan, January 23-27, 2000; IEEE, January 23, 2000; pages 341 – 346.	

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